IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Tongbi Jiang et al.

Art Unit:

3729

Serial No.:

10/689,471

Examiner:

Minh N. Trinh

Filed:

October 20, 2003

Docket:

MCT.0015C2US

97-0524.04/US

For:

A Method for Forming a Stencil (As Amended)

Mail Stop AF Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed June 23, 2006, please amend the abovereferenced patent application as follows: